

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Christopher M. Look

Application No.: 10/785,618

Filed: February 23, 2004

Attorney Docket No.: 6518P009

For: **METHOD AND AN APPARATUS
TO PROVIDE OPTICAL EQUIPMENT
PROTECTION**

Examiner: Wai Lun Leung

Art Unit: 2613

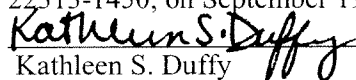
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AMENDMENT AND RESPONSE AFTER FINAL OFFICE ACTION

In response to the final Office Action mailed July 24, 2008, please enter the following amendments and consider the following remarks. A Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 accompanies this response.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this paper is being transmitted online via EFS Web to the Patent and Trademark Office, Commissioner for Patents, Post Office Box 1450, Alexandria, Virginia 22313-1450, on September 19, 2008.

 9/19/08
Kathleen S. Duffy September 19, 2008